

10/588187

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PATENT  
8007-1114

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Hiroki SATO et al.

Conf.

Application No. **NEW NATIONAL PHASE**

Group

Filed August 2, 2006

Examiner

ALKOXIDE COMPOUND, MATERIAL FOR THIN FILM FORMATION, AND PROCESS  
FOR THIN FILM FORMATION

**PRELIMINARY AMENDMENT**

Assistant Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

August 2, 2006

Sir:

The following preliminary amendments and remarks are respectfully submitted in connection with the above-identified application.

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begin on page 3 of this paper.

**Remarks** begin on page 6 of this paper.

An **Appendix** is attached following the signature page of this paper.